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## \*BIBDATASHEET\*

Bib Data Sheet

**CONFIRMATION NO. 7110** 

<b>SERIAL NUMBER</b> 09/775,209	FILING OR 371(c)	<b>CLASS</b> 356		GROUP ART UNIT 2877		ATTORNEY DOCKET NO. JG-SU-5038 / 500577.2				
APPLICANTS  Mohammad B. Shabani, Tokyo, JAPAN; Shigeru Okuuchi, Tokyo, JAPAN;  ** CONTINUING DATA **********************************										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/13/2001										
Foreign Priority claimed yes no  35 USC 119 (a-d) conditions yes no Met after Allowance  Verified and Acknowledged Examiner's Signature Initials			STATE OR COUNTRY JAPAN	SHEETS DRAWING 3		TOTAL CLAIMS 20		INDEPENDENT CLAIMS 2		
ADDRESS 26418										
TITLE METHOD FOR ANALYZING IMPURITIES IN A SILICON SUBSTRATE AND APPARATUS FOR DECOMPOSING A SILICON SUBSTRATE THROUGH VAPOR-PHASE REACTION										
*					All Fees					
RECEIVED No.	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOU No for following:			NT	1.16 Fees ( Filing )  1.17 Fees ( Processing Ext. of time )					
				Other Credit						